

## Measurement the Spectroscopic Temperature of Electron in Aluminum Laser Induced Plasma

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### Abstract

In this research, optical emission spectroscopic studies have been carried out in Aluminum plasma generated using 1064nm, 10ns pulses from Nd:YAG laser. Temperature was estimated from the analysis of spectral data. The temperature values measurements have been performed by the comparison of two selected spectral lines of the radiation emitted by laser induced plasma of Al using singly ionized Al atom and neutral lines. An initial temperature of 2.6 eV was measured. The relation between electron temperature and laser pulse energy in the laser-generated Al plasma have been analyzed. The electron temperatures values are found to increase from 2.6 eV to 2.8 eV then to 2.9 eV as increasing laser pulse energy. [DOI: [10.22401/JUNS.20.2.10](https://doi.org/10.22401/JUNS.20.2.10)]

Keywords: Laser induced plasma, Spectrometer, electron temperature, plasma physics, plasma plume.

### Introduction

The interaction of laser pulses with solids, liquids and gases had many technological applications ranging from laser processing of solids, laser-induced mass spectrometry to film deposition by pulsed lasers and has gained currency in both fundamental and applied studies.[1-4]. Laser-created plasma characteristics are strongly dependent upon several key parameters, including laser intensity, pulse duration and wavelength, target material and geometry, and the nature and pressure of any ambient gas.[5,1,3]. The laser energy transferred to target material through electrons involves different mechanisms, viz. electron-phonon coupling, multi-photon ionization and cascade ionization, etc. [3]. The laser induced evaporation and ionization is separated into three domains: (i) heat conduction inside the solid, (ii) the evaporation wave attached to the solid surface, and (iii) expansion of the high temperature vapor [6]. By increasing the fluence over the ablation threshold, the saturation of the produced plasma density allows the increase of the ions and electrons temperatures [7]. Because of the transient features of the plasma created by LIP, optical emission spectroscopy (OES) technique with time and space resolution is especially used to obtain information about the behavior of the created plasma species in space and time as well as the dynamics of the

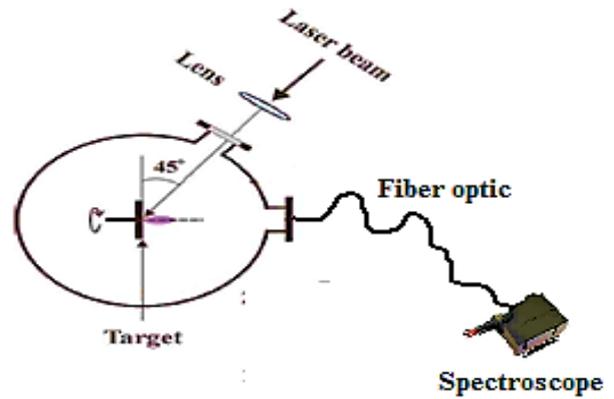
plasma evolution [8-10]. The ratio for intensity of two lines of the same species of ionization stage Z in the emission spectrum of the target ablated b laser is expressed as:

$$\frac{I_1}{I_2} = \left( \frac{\lambda_{ki,Z}}{\lambda_{nm,Z}} \right) \left( \frac{A_{ki,Z}}{A_{nm,Z}} \right) \left( \frac{g_{k,Z}}{g_{n,Z}} \right) \exp \left( - \frac{E_{k,Z} - E_{n,Z}}{k_B T_e} \right) \dots \dots \dots (1) [10]$$

where  $I_1$  is the line intensity from the k-i transition (arbitrary unit),  $I_2$  is that from the n-m transition (arbitrary unit),  $\lambda_{ki,Z}$  is the wavelength from the k-i transition (nm),  $\lambda_{nm,Z}$  is the wavelength from the n-m transition (nm),  $A_{ki,Z}$  is the transition probability from the k-i transition ( $s^{-1}$ ),  $A_{nm,Z}$  is the transition probability from the n-m transition ( $s^{-1}$ ),  $g_{k,Z}$  is the statistical weight of the k state,  $g_{n,Z}$  is the statistical weight of the n state,  $E_{k,Z}$  is the energy of the k state (eV),  $E_{n,Z}$  is the energy of the n state (eV),  $k_B$  is the Boltzmann constant  $1.38 \times 10^{-23} \text{ J.K}^{-1}$ , and  $T_e$  is the electron temperature (eV). From equation (1) we can find the electron temperature  $T_e$  by comparison of two spectral lines in the emission spectrum [10]. The aim of this research is to estimate electron temperature  $T_e$  of plasma produced by Nd:YAG pulsed laser of Al element which can be used in many application such as electrooptics devices and semiconductors alloys.

**Experimental Work**

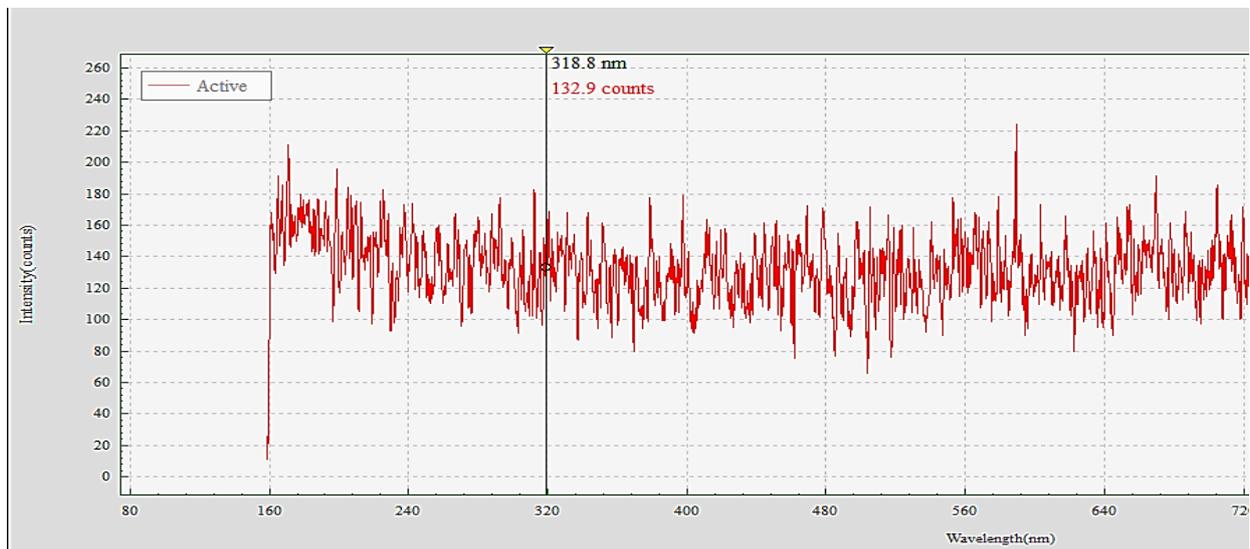
The target of the laser induced plasma (LIP) process was Al with purity 99.999%, and compressed under the pressure (10 tons) in order to make it shaped liked disc with about a diameter of 3cm and then sintered in the oven to temperature T (400C<sup>0</sup>) for two hours. LIP experiment was achieved under vacuum pressure 0.1mbar by using Varian DS219 Rotary pump. The beam of Nd: YAG laser with fundamental harmonic frequency ( $\lambda=1064\text{nm}$ , 10ns, 6Hz) was focused onto Al target with quartz lens f=10cm, the target was kept onto a rotating motor at a speed 4 rev/min to prevent fast drilling. The spectroscope used to collect the emission radiation from the plasma was of the type Surwit S3000-UV-NIR. The LIP experiment was performed at room temperature. LIP setup scheme has been shown in Fig.(1). Electron temperature of the Al ablated atoms were calculated by analyzing the emission line spectra of the spectroscope data. The Al target was ablated by 1000 pulses. The vacuum pressure was varied from 0.04 to 0.2 mbar, also the laser pulse energy was selected to be 800,860, and 940mJ to study their effects on the value of electron temperature.



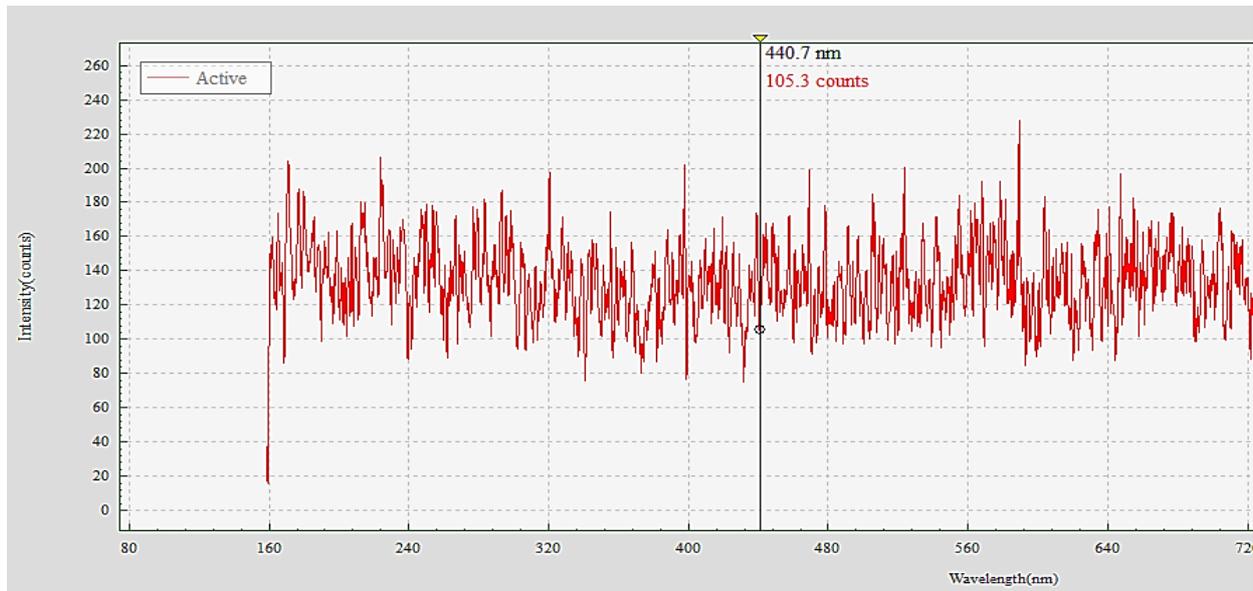
**Fig.(1): Schematic diagram of the LIP experimental setup.**

**Results and Discussion**

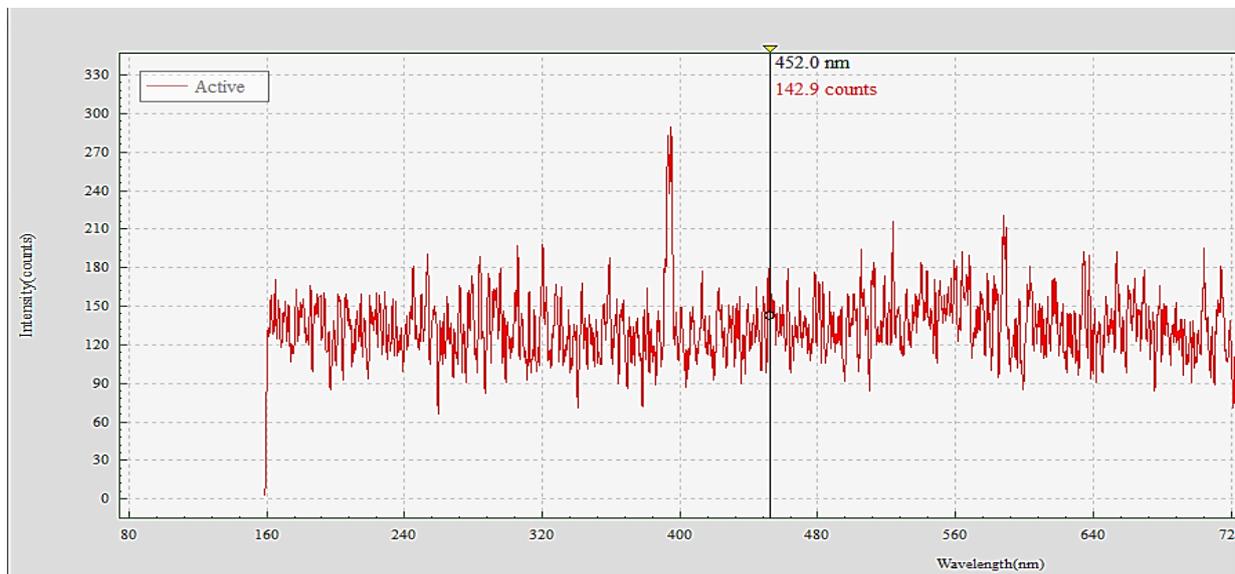
Different laser pulse energies 800,860, and 940mJ on Al sample has been done, and by using the spectrometer and comparing with NIST database a certain peaks as shown in table 1 has been taken from the figure between the wavelength and the intensity as in figures 2,3, and 4.



**Fig.(2): Emission spectrum of Al plasma at laser pulse energy 940mJ.**



**Fig.(3): Emission spectrum of Al plasma at laser pulse energy 860mJ.**



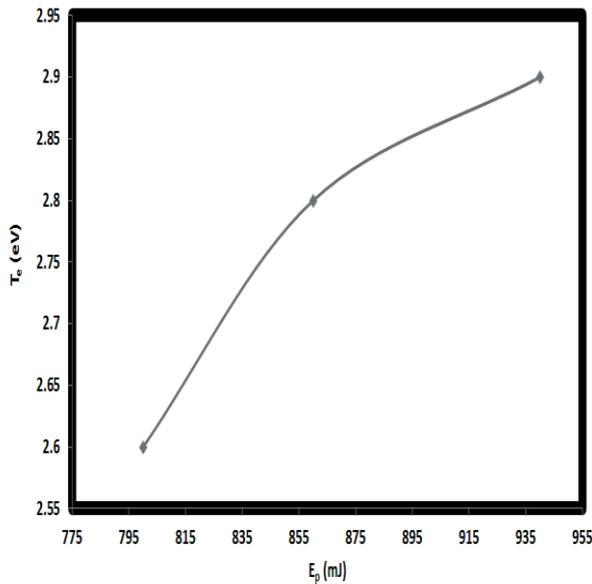
**Fig.(4): Emission spectrum of Al plasma at laser pulse energy 800mJ.**

The electron temperature can be calculated as shown in Table (1).

**Table (1)**  
**Experimental and result data.**

$E_{Laser}$	$I_1$	$I_2$	$g_k A_{ki}$	$g_n A_{nm}$	$\lambda_{ki}$	$\lambda_{nm}$	$E_n$	$E_k$	$T_e$
800	174.9	145.4	$2.57 \times 10^6$	$8.24 \times 10^7$	209.9	214.5	0	5.94	2.6
860	153.6	179.3	$1.95 \times 10^8$	$8.24 \times 10^7$	209.3	214.5	0.014	5.933	2.8
940	139.9	159.4	$7.75 \times 10^8$	$8.24 \times 10^7$	208.5	214.5	0.014	5.919	2.9

The proportional relation between the laser pulse energies and the electron temperature has been shown in Fig.(5).



**Fig.(5): Laser pulse energy as a function of the electron temperature.**

Fig.(5) shows the relation between the electron temperature and laser pulse energy. It is noted from Fig.(5) that the temperature of electron increases remarkably with increasing energy because at this energy level higher energy is transferred.

These results and behavior agree with results and behavior of D. M. Surmick and C. G. Parigger as in [11]. The area nearby the surface of the target material will absorb radiation during the exposition time of laser pulse, in charge of enabling the electron to gain temperature. The high value of the electron temperature close to the surface belongs to the absorption of laser pulses by inverse bremsstrahlung absorption mechanism. Such manner of the electron temperature in Fig.(5) is due to the absorption or reflection of the laser pulse energy by plasma and relies on the frequency of plasma. It is noted also extra excited species, such as ion and free electrons because of increasing laser intensity. The laser pulse interacts with ions and free electrons and more heating, ionization and exhaustion of the arriving laser energy have been got. The electron temperature  $T_e$  has been calculated by using eq.(1) by comparing the spectral lines 318.8nm, 440.7nm and 452nm which belong to Al III, Al IV, and Al III respectively.

### Conclusions

The influence of Q-switched Nd:laser on Al plasma produced by the principle harmonic wavelength on electron temperature

and its manner as a function of laser pulse energy on the created plasma. The results disclose that the temperature of electron increases as laser pulse energy increases. The relation between them is directly proportional. The technique used for finding electron temperature is spectroscopic method by comparing two atomic line of Al target plasma induced by laser, from the comparison between these two lines electron temperature  $T_e$  has been found.

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